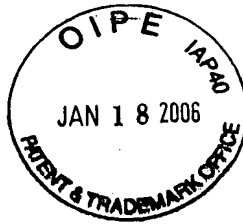


Docket Number: 081468-0308663

Client Reference: P-1621.010-US



ZFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

ALBERT JAN HENDRIK KLOMP, et al.      Group Art Unit: 3652

Application No.: 10/797,608

Examiner: UNKNOWN

Filed: March 11, 2004

Confirmation No.: 4060

For: TEMPERATURE CONDITIONED LOAD LOCK, LITHOGRAPHIC APPARATUS  
COMPRISING SUCH A LOAD LOCK AND METHOD OF MANUFACTURING A  
SUBSTRATE WITH SUCH A LOAD LOCK

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. One copy of each non-U.S. reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the references have been considered, per MPEP § 609.

This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

An English language version of a Korean Office Action that issued in a related application, and English-language Abstracts of the non-English language patent references are attached hereto.

Respectfully Submitted,



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Atty.  
Dkt. No.

M#

Client Ref.

0308663

P-1621.010-US

# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Applicant: KLOMP et al.

Appln. No.: 10/797,608

Filing Date: March 11, 2004

Date: January 18, 2006

Page

1

of

1

Examiner: UNKNOWN

Group Art Unit: 3652

## U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR 2003/0082030	A1 05/01/2003	DEL PUERTO et al.			
	BR 6,281,510	B1 08/28/2001	YOSHITAKE et al.			
	CR 5,730,573	A 03/24/1998	MASUJIMA et al.			
	DR 6,906,783	B2 06/14/2005	DEL PUERTO et al.			
	ER 2004/0218168	A1 11/04/2004	VAN GROOS et al.			
	FR 2004/0263823	A1 12/30/2004	KLOMP et al.			
	GR					
	HR					
	IR					
	JR					
	KR					
	LR					
	MR					

## FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor or Applicant Name	English Abstract		Translation Readily Available	
					Enclosed	No	Enclosed	No
	NR 1 341 042	A2 09/03/2003	European Patent Office	ASML NETHERLANDS B.V.				
	OR 2001-222099	A 08/17/2001	Japan	TOSHIBA CORP	X			
	PR 9-246347	A 09/19/1997	Japan	APPLIED MATERIALS INC	X			
	QR 1 341 042	A3 03/31/2004	European Patent Office	ASML NETHERLANDS B.V.				
	RR							
	SR							
	TR							
	UR							

## OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

VR	Korean Office Action in Korean Application No. 10-2004-0016527 dated October 31, 2005			X
WR				
XR				
YR				
ZR				

Examiner

Date Considered:

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.